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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Appl. No. : 10/045,766
Applicants : Tuttle et al.
Filed : 10/23/2001
Docket No. : 5000.142

Confirmation No: 3061
Art Unit: 2812
Examiner: Andre C. Stevenson

For : PATTERN FOR IMPROVED VISUAL INSPECTION OF
SEMICONDUCTOR DEVICES

April 15, 2004

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

This responds to the Office Action mailed December 29, 2003.

Amendments to the Claims begin on page 2 of this paper.

Remarks and arguments begin on page 7 of this paper.